



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 1, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG842619493

LABORATORY GROWN DIAMOND

CUSHION MIXED CUT

11.62 X 7.40 X 4.69 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

3.70 CARATS

D

VVS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

NONE

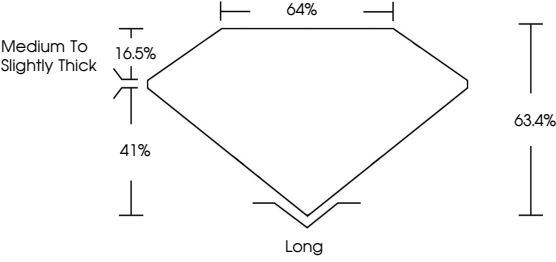
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

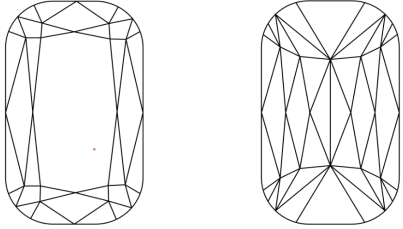


LG842619493

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

Sample Image Used



COLOR

FL

IF

VVS 1-2

VS 1-2

SI 1-2

I 1-3

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

CLARITY

FL

IF

VVS 1-2

VS 1-2

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CUSHION MIXED CUT

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Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Medium to Slightly Thick

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

3.70 CARATS

D

VVS 1

63.4%

64%

Medium to Slightly Thick

Long

EXCELLENT

EXCELLENT

NONE

IGI LG842619493

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www.igi.org

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